

Special Issue

State-of-Art in Optical Tweezers

Message from the Guest Editors

Optical tweezers (OTs) enable trapping and manipulation without contact and apply minute forces on microscopic particles. Since the pioneering work of Arthur Ashkin, OTs have been developed at a dazzling speed. To maintain the pace in recent advancements regarding OTs, the Special Issue, entitled “State of the Art in Optical Tweezers”, welcomes contributions regarding all aspects of optical trapping and manipulation. Theoretical and experimental studies are welcome, as well as articles concerning applications of OT in all the fields of science. This Special Issue will accept all forms of contributions, including research papers, communications and review articles.

Guest Editors

Dr. Ruben Ramos-Garcia

Instituto Nacional de Astrofísica, Óptica y Electrónica (INAOE), Luis Enrique Erro #1. Sta Maria Tonantzintla, Puebla 72840, Mexico

Prof. Dr. Gabriel Spalding

Laboratory for Mesoscopics & Quantum Microscopies, Illinois Wesleyan University, Bloomington, IL 61701, USA

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Micromachines
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
micromachines@mdpi.com

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Editor-in-Chief

Prof. Dr. Ai-Qun Liu

1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China
2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

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